I hereby certify that this correspondence is being deposited with the United States Postal Service on the date set forth below as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D. C. 20231.

Date of Signature and Deposit: September 26, 2001

Attorney of Record

0 1 2001

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Richard D. Harris

Serial No.:

09/843,545

Filed:

April 26, 2001

For:

Method for Fabricating an Isolated Microelectromechanical

System (MEMS) Device Using an Internal Void

Group Art Unit:

2812

Docket No.:

01AB021

## INFORMATION DISCLOSURE STATEMENT

**Commissioner For Patents** Washington, D.C. 20231

Sir:

This is an Information Disclosure Statement pursuant to 37 C.F.R. §§ 1.97 and 1.98. It is Applicants' understanding that a first Office Action on the merits has not yet been mailed in this application, and that therefore 37 C.F.R. § 1.97(b) is applicable (so that this art may be considered without further requirements).

In the event that a first Office Action has been mailed having a mailing date prior to the filing of this Statement, thereby rendering 37 C.F.R. § 1.97(b) inapplicable, Applicants hereby, pursuant to Rule 97(c), authorize the payment of \$240.00 by charge to Deposit Account 17-0055 in order to permit consideration of this art. The Commissioner is also hereby authorized to deduce.

fees needed for consideration of this art from Deposit Account No. 17-0055. PECE/VED

The attached form PTO-1449 constitutes the required list of supplied

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## 2. Copies

Attached hereto is a legible copy of each item listed on the form PTO-1449.

Respectfully submitted,

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